

TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT**(Under 37 CFR 1.97(b) or 1.97(c))**

Docket No.

SKI.008C2

In Re Application Of: **Shunji Hayashi**

APR 08 2004

Serial No.

10/712,100

Filing Date

November 14, 2003

Examiner

Unknown

Group Art Unit

2825

Title: **METHOD AND SYSTEM FOR MANAGING SEMICONDUCTOR MANUFACTURING EQUIPMENT**

Address to:

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

37 CFR 1.97(b)

1. ☒ The Information Disclosure Statement submitted herewith is being filed within three months of the filing of a national application other than a continued prosecution application under 37 CFR 1.53(d); within three months of the date of entry of the national stage as set forth in 37 CFR 1.491 in an international application; before the mailing of a first Office Action on the merits, or before the mailing of a first Office Action after the filing of a request for continued examination under 37 CFR 1.114.

37 CFR 1.97(c)

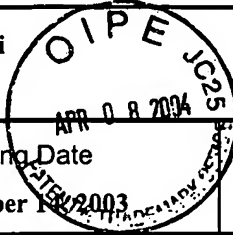
2. ☐ The Information Disclosure Statement submitted herewith is being filed after the period specified in 37 CFR 1.97(b), provided that the Information Disclosure Statement is filed before the mailing date of a Final Action under 37 CFR 1.113, a Notice of Allowance under 37 CFR 1.311, or an Action that otherwise closes prosecution in the application, and is accompanied by one of:
- ☐ the statement specified in 37 CFR 1.97(e);
- OR**
- ☐ the fee set forth in 37 CFR 1.17(p).

Note: The enclosed references were cited in copending U.S. Application Serial No. 10/125,403, and thus may be material to the prosecution of the present application.

TRANSMITTAL OF INFORMATION DISCLOSURE STATEMENT
(Under 37 CFR 1.97(b) or 1.97(c))

Docket No.
SKI.008C2

In Re Application: Shunji Hayashi



Serial No.

10/712,100

Filing Date

November 19, 2003

Examiner

Unknown

Group Art Unit

2825

METHOD AND SYSTEM FOR MANAGING SEMICONDUCTOR MANUFACTURING

Payment of Fee

(Only complete if Applicant elects to pay the fee set forth in 37 CFR 1.17(p))

- ☐ A check in the amount of _____ is attached.
- ☒ The Director is hereby authorized to charge and credit Deposit Account No. **50-0238** as described below.
- ☐ Charge the amount of _____
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Signature

Dated: April 8, 2004

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re PATENT APPLICATION of

Shunji Hayashi

Examiner: Unknown

Serial No.: 10/712,100

Attorney Docket No. SKI.008C2

Filed: November 14, 2003

Art Unit No.: 2825

For: METHOD AND SYSTEM FOR MANAGING SEMICONDUCTOR
MANUFACTURING EQUIPMENT

LETTER OF RELATED APPLICATION

U.S. Patent and Trademark Office
2011 South Clark Place
Crystal Plaza Two, Lobby, Room 1B03
Alexandria, VA 22202

Date: April 8, 2004

Sir:

The Examiner is hereby advised of co-pending U.S. Application Serial No. 10/125,403. The subject matter contained in this co-pending U.S. Application Serial No. 10/125,403 is related to the present application and thus may be material to the prosecution of this instant application.

This application is not to be construed as prior art. By bringing this application to the attention of the Examiner, Applicant does NOT waive the confidentiality provisions of 35 U.S.C. 122.

Respectfully submitted,

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